

**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1775**

Attorney Docket No. 5649-921

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Gi-Jung Kim et al.
Serial No. 10/601,475
Filed: June 23, 2003

Confirmation No. 7249
Group Art Unit: 1775
Examiner: Elizabeth D. Ivey

For: **SEMICONDUCTOR WAFERS HAVING ASYMMETRIC EDGE
PROFILES THAT FACILITATE HIGH YIELD PROCESSING BY INHIBITING
PARTICULATE CONTAMINATION (AS AMENDED)**

Date: March 15, 2007

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1451

AMENDMENT AFTER FINAL

Sir:

This response addresses the final Official Action of December 18, 2006.